Title: Apparatus and Method to Achieve Cartinuous Interface and Ultrathin Film During Atomic La. Deposition

Inventor(s): Ofer Sneh, et al. Attorney Docket No.: 4551P002D

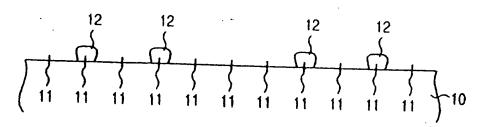


FIG. 1 (Prior Art)

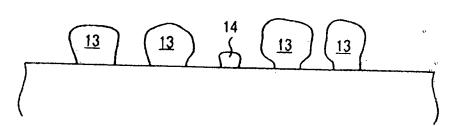


FIG. 2 (Prior Art)

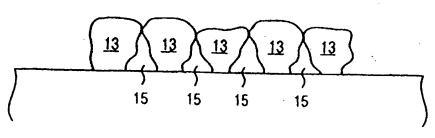
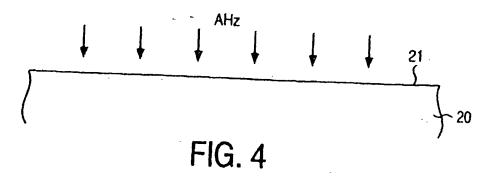
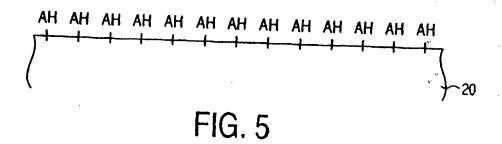


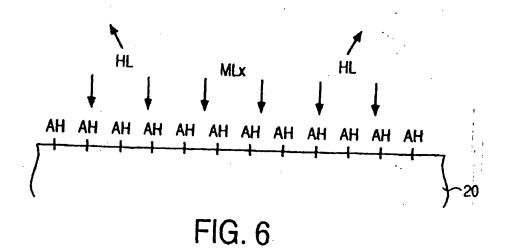
FIG. 3 (Prior Art)

Title: Apparatus and Method to Achieve Continus Interface and Ultrathin Film During Atomic Layer Legislator (2): Office Continuity (2): O

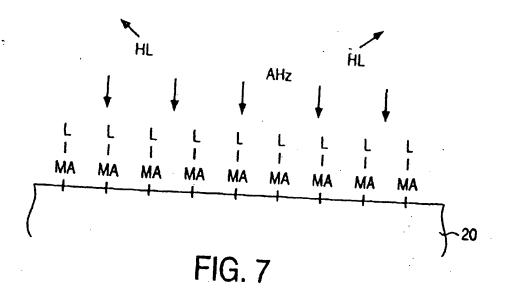
Inventor(s): Ofer Sneh, et al. Attorney Docket No.: 4551P002D







ventor(s): Ofer Sneh, et al. Attorney Docket No.: 4551P002D



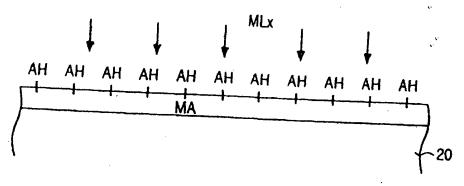
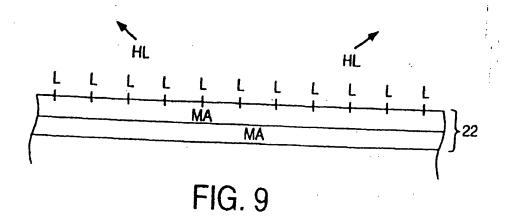


FIG. 8



Title: Apparatus and Method to Achieve Cor nous Interface and Ultrathin Film During Atomic Laye. position

Inventor(s): Ofer Sneh, et al. Attorney Docket No.: 4551P002D

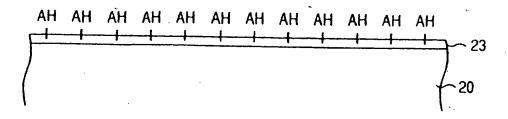


FIG. 10

